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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Donald W. Berrian et al.
Serial No: 09/990,848
Confirmation No: 2772
Filed: November 21, 2001
For: HYBRID SCANNING SYSTEM AND METHODS FOR ION IMPLANTATION
Examiner: Johnnie L. Smith
Art Unit: 2881

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Sir:

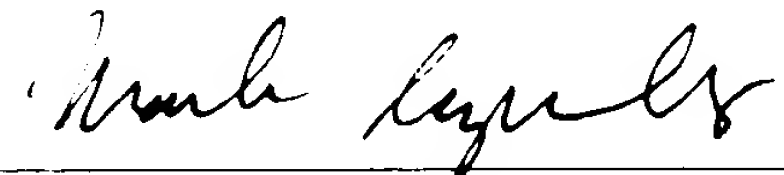
Transmitted herewith are the following documents:

- ☒ Response to Office Extension
- ☒ Three-month Petition for Extension of Time
- ☒ Return Receipt Postcard

If any fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited.

Respectfully submitted,

Donald W. Berrian et al. , Applicants

By: 

Mark A. Superko, Reg. No. 34,027
Varian Semiconductor Equipment
Associates, Inc.
35 Dory Rd.
Gloucester, Massachusetts 01930-2297
Telephone: (978) 282-5915

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